

Application/Control No.	Applicant(s)/Patent under Reexamination	
09/895,768	CHU ET AL.	
Examiner	Art Unit	
Jin-Cheng Wang	2628	

SEARCHED						
Class	Subclass	Date	Examiner			

INTERFERENCE SEARCHED						
Class	Subclass	Date	Examiner			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
STIC online catalog (adobe effect under keyword search)	8/5/2006	JCW		